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2825

PATENT
Attorney Docket No. SEL 156 DIV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
Shunpei Yamazaki, et al.)
Serial No.: 09/874,670)
Filed: June 5, 2001)
Examiner: Lalrinfamkin Hmar Malsawma)
Art Unit: 2825)
For: SEMICONDUCTOR DEVICE AND)
MANUFACTURING METHOD THEREOF)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 on
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Shannon Wallace
Name of applicant, assignee, or Registered Rep.
Shannon Wallace 8/19/04
Signature Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT D

Sir/Madam:

In response to the Office Action mailed March 3, 2004, a three month extension of time being submitted herewith, please amend the above-identified patent application as follows.

IN THE DRAWINGS:

The attached sheets of drawings include changes to Figs. 1 and 3C to complete the line of the upper surface of the insulating film 131. This error occurred in the preparation of the formal drawings.

Attachment: Replacement Sheets

Annotated Sheets Showing Changes